Search Notes

Application/Control No.	Applicant(s)/Patent under Reexamination	
10/629,430	CHOI ET AL.	
Examiner	Art Unit	
Jennifer M. Kennedy	2812	

SEARCHED					
Class	Subclass	Date	Examiner		
438	253-256	4/11/2005	JMK		
438/	396-399	4/11/2005	JMK		
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INTERFERENCE SEARCHED					
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DATE	EXMR
4/11/2005	JMK
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